

HIGH-FREQUENCY SEMICONDUCTOR DEVICE

BACKGROUND OF THE INVENTION

1. Field of the Invention

The present invention relates to a high-frequency semiconductor device, particularly to the patch antenna provided in an MMIC (Monolithic Microwave Integrated Circuit).

2. Related Prior Art

MMICs comprising high-speed semiconductor devices such as represented by HEMT (High Electron Mobility Transistor) or HBT (Hetero-Bipolar Transistor) are provided with an antenna for receiving and transmitting signals from/to the outside. Antenna called patch antenna is known as what is easy to integrate with MMICs.

FIG.1 is a see-through plan view for explaining a conventional patch antenna, and FIG.2 is a cross-sectional view taken on segment line A-A' in FIG.1.

Referring to FIGs.1 and 2, conventional patch antenna 100 has a structure comprising semiconductor substrate 1 provided with surface insulation film 2 protecting the surface thereof, antenna-ground plane 3 provided thereon, which is to be connected to the ground potential, and patch electrode 6 and antenna line 6a for supplying power to patch electrode 6 (or extracting power from patch electrode 6), both formed on antenna-ground plane 3 with interlayer insulation film 5 therebetween.

The conventional patch antenna described with reference to FIGs.1 and 2 can be formed from a planer metallization pattern, and easily integrated in an MMIC.

Patch electrode 6 corresponds to the feeding portion of the antenna, and its shape plays a

substantial role in determining the characteristics of the antenna. However, it is necessary to connect antenna line 6a to patch electrode 6, and this results in that the effective patch electrode has a shape of combining the respective patterns of patch electrode 6 and antenna line 6a. Thus, the conventional patch antenna necessarily includes the pattern of antenna line 6a, and the antenna characteristics, for example, radiation pattern, deviate from the ideal values obtained from the design based on only patch antenna 6.

SUMMARY OF THE INVENTION

It is an object of the present invention to provide an MMIC having a patch antenna with improved antenna characteristics.

It is another object of the present invention to provide a method for increasing freedom in a patch antenna pattern design.

It is still another object of the present invention to provide a method for preventing patch electrode from the influence of antenna line 6a.

FIG.3 is a see-through plan view for explaining the essential concept of the present invention, and FIG.4 is a cross-sectional view taken on segment line A-A' in FIG.3.

As shown in the drawings, antenna line 6a as the antenna connection portion is formed under antenna ground plane 3, and is connected to the lower surface of patch electrode 6 via through-hole 7.

According to the present invention, antenna line 6a is not formed on the top surface of interlayer insulation films 5, and the pattern shape of patch electrode 6 can be free from antenna line 6a, and thus, the antenna characteristics can be improved.

BRIEF DESCRIPTION OF THE DRAWINGS

FIG.1 is a see-through plan view for explaining a conventional patch antenna;

FIG.2 is a cross-sectional view taken on segment line A-A' in FIG.1;

FIG.3 is a see-through plan view for explaining the essential concept of the present invention;

FIG.4 is a cross-sectional view taken on segment line A-A' in FIG.3;

FIG.5 is a see-through plan view for explaining the first embodiment of an MMIC according to the present invention;

FIG.6 is a cross-sectional view taken on segment line A-A' in FIG.5;

FIG.7 is a see-through plan view for explaining the second embodiment of an MMIC according to the present invention;

FIG.8 is a cross-sectional view taken on segment line A-A' in FIG.7;

FIG.9 is a see-through plan view for explaining the third embodiment of an MMIC according to the present invention;

FIG.10 is a cross-sectional view taken on segment line A-A' in FIG.9;

FIG.11 is a see-through plan view for explaining the fourth embodiment of an MMIC according to the present invention; and

FIG.12 is a cross-sectional view taken on segment line A-A' in FIG.11.

DESCRIPTION OF THE PREFERRED EMBODIMENT

The embodiments of the present invention will be described in the following, with reference to drawings.

FIG.5 is a see-through plan view for explaining the first embodiment of an MMIC according to the present invention. FIG.6 is a cross-sectional view taken on segment line A-A' in FIG.5.

In this embodiment, GaAs compound semiconductor substrate 1 is employed, on which surface insulation film 2 composed of silicon nitride is provided after active devices such as FETs are built therein (not shown). Ground plate 8 composed of gold (Au) is formed on surface insulation film 2, which is connected to the ground potential via a not-shown wiring or through-hole, and further, antenna line 6a, antenna ground plane 3 which is connected to the ground potential, and patch electrode 6 are successively formed thereon with respective interlayer insulation films 5 therebetween. Antenna line 6a forms a high-frequency transmission line together with ground plate 8, and, line conductors 9 each forming a high-frequency transmission line together with ground plate 8 are formed in a region except that for patch antenna 100. Antenna line 6a and patch electrode 6 are interconnected by through-hole 7 passing through a cut-off pattern formed in antenna ground plane 3, and the electrical conduction is established by through-hole conductor 7a.

Each of interlayer insulation films 5 is composed of a polyimide or benzocyclobutene (BCB), and each of antenna line 6a, antenna ground plane 3, patch electrode 6 and line conductors 9 is composed of gold (Au) deposited by using a technology such as sputtering or vacuum deposition, and is patterned by using a technology such as ion milling or lift-off. Through-hole conductor 7a is formed of gold (Au) filled by using plating technology, for example.

According to this embodiment, there is no need for antenna line 6a and patch electrode 6 to be connected each other on a common surface, and antenna line 6a does not affect the pattern shape of patch electrode 6.

FIG.7 is a see-through plan view for explaining the second embodiment of an MMIC according to the present invention, and FIG.8 is a cross-sectional view taken on segment line A-A' in FIG.7.

In this embodiment, antenna ground plane 3 to be connected to the ground potential is widened up to the region where it has no longer any effect for functioning as antenna but can be used as a ground plate. That is, when a line conductor 9 is arranged over antenna ground plane 3 in such region with interlayer insulation film 5 therebetween, it can form a high-frequency transmission line together with the antenna ground plane 3.

FIG.9 is a see-through plan view for explaining the third embodiment of an MMIC according to the present invention, and FIG.10 is a cross-sectional view taken on segment line A-A' in FIG.9.

In this embodiment, line conductor 9 is formed under antenna ground plane 3. Antenna ground plane 3 is to be connected to the ground potential, and therefore, the antenna characteristics does not suffer from the structure under patch antenna 100, in particular, and the integration of MMICs can accordingly be facilitated by providing line conductors 9 under antenna ground plane 3. Besides line conductors, other passive devices (capacitor, inductor, and resistor) may be provided under antenna ground plane 3.

FIG.11 is a see-through plan view for explaining the fourth embodiment of an MMIC according to the present invention, and FIG.12 is a cross-sectional view taken on segment line A-A' in FIG.11.

In this embodiment, antenna ground plane 3 functions as the ground plane throughout an MMIC. That is, line conductors 9 are provided in a region where antenna ground plane 3 does not substantially influence on the antenna function, and antenna ground plane 3 functions as the ground plane of high-frequency transmission lines. Further in this embodiment, none

of antenna line is employed, and active region 1a formed in semiconductor substrate 1 is used as an antenna connection.

According to this embodiment, antenna ground plane 3 is incidentally used as the ground plane, and the process for forming the ground plate can be omitted.

It should be understood that the present invention is not limited to those explained with reference to the above embodiments, and may reside in various modifications. Although a rectangular-shaped patch electrode, for instance, has been shown in the embodiments, the present invention may be applicable to a patch electrode having another shape such as circle, according to the several modes of applications, including the shape of the enclosure like package, the power feeding position, the need for plural power feedings, and so forth. Further, a conductor other than gold (Au) may be employed for the patch electrode and ground plane, in this regard, a super conductive material may be used.

According to the present invention, the antenna is not limited to a single patch antenna as explained above but may be composed of plural patch antennas disposed in a patch antenna array, for instance.

As explained above, the present invention enables the pattern shape of a patch electrode to be free from the influence of an antenna line connected thereto, and therefore, a high-frequency semiconductor device having an antenna of excellent characteristics can be provided.